

*Igw  
AF*

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Jong-Sun PEAK

Art Unit: 2624

Serial No. 10/617,766

Examiner: Kathleen S. Yuan

Filed: July 14, 2003

*Confirmation No.* 4047For: METHOD FOR RECOGNIZING A PATTERN OF  
AN ALIGNMENT MARK ON A WAFER

Attorney Docket No. 253/027

AMENDMENT UNDER 37 C.F.R. § 1.116

Mail Stop: **BOX AF**  
Commissioner for Patents  
United States Patent and Trademark Office  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

In response to the Office Action Made Final mailed October 30, 2007, the following amendments and remarks are respectfully submitted in connection with the above-identified application:

**Amendments to the Claims** are reflected in a listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.